# Gate Voltage Dependent 1/f Noise Variance Model in n-Channel MOSFETs

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Supported by STARC

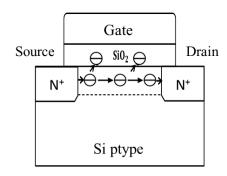
# Outline of our Research

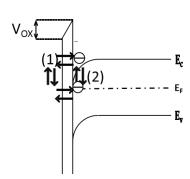
## **Research Purpose**

> Development of 1/f noise variance model in MOSFETs

## **Research Approach**

1/f noise caused by Mobility Fluctuation and Interface Traps





Increase of

from the Si to the gate oxide between interface traps

Oscillator Circuits Noises

SPICE2 type model



- ① Interface Trap Number
- 2 Mobility Fluctuation
- 3 Process Variation
- 4 Time & Temperature Degradation



### **Research Goal**

- Present the model derivation
- Implementation on our SPICE3 (MDW-SPICE) circuit simulator

# Research Results

#### **SPICE2 Model**

**Hooge's 1/f Model**: Mobility Fluctuation Model

$$S_{I_D} = \frac{KF \cdot I_{ds}^{AF}}{C_{OX} L_{eff}^2 f^{EF}}$$

$$S_{I_D} = \frac{\alpha_H \cdot \mu_{eff} \cdot 2kT \cdot I_D}{fL^2}$$

#### **Comparison with These Models**

→ Variability model incorporated in mobility fluctuations

$$KF = C_{OX} \cdot \mu_{eff} \cdot 2 \cdot k \cdot T \cdot \alpha_{H_{nominal}} \cdot D \cdot e^{-(V_{gs} - V_{th})}$$

#### **Simulation and Measurement Results**

Proposed model agreed with measurement results!



